

Notice of References Cited	Application/Control No. 10/631,185	Applicant(s)/Patent Under Reexamination CHAUVEL ET AL.	
	Examiner Arpan P. Savla	Art Unit 2185	Page 1 of 1

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*	B	US-5,893,121	04-1999	Ebrahim et al.	707/206
*	C	US-6,026,485	02-2000	O'Connor et al.	712/226
*	D	US-6,801,986	10-2004	Steely et al.	711/152
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.